

## United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Vignia 22313-1450 www.uspto.gov

## \*BIBDATASHEET\*

Pih Data Shoot

**CONFIRMATION NO. 4884** 

Bib Data Sneet										
SERIAL NUMBE 10/786,925	FILING DATE 02/24/2004 RULE		C	CLASS 349		GROUP ART UNIT 2871		ATTORNEY DOCKET NO. JP920000098US		
APPLICANTS										
Takatoshi Tsujimura, Fujisawa-shi, JAPAN;										
Osamu Tokuhiro, Shiga-ken, JAPAN; Kohichi Miwa, Yokohama-shi, JAPAN;Mitsuo Morooka, Kawasaki-shi, JAPAN;										
** CONTINUING DATA **********************************										
** FOREIGN APPLICATIONS ************************************										
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/17/2004										
Foreign Priority claimed 35 USC 119 (a-d) conditi	ione	yes no Met afte		STATE OR	SHE	EETS	тот	AL	INDEPENDENT	
met Verified and Acknowledged		Allowance T.	er Litiáls	COUNTRY JAPAN		WING 8	CLAII 8		CLAIMS 2	
ADDRESS David Aker 23 Southern Road Hartsdale , NY 10530										
TITLE Active matrix substrate and manufacturing method thereof										
						□ All	☐ All Fees			
						1.16 Fees ( Filing )				
FILING FEE						1.17 Fees ( Processing Ext. of time )				